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U.S. Patent Documents

Examiner Initial		Patent Number	Date	Name	Class	Sub-Class	Filing Date
ju	AA	6,277,339	8/21/2001	Bonberg et al.	422	198	7/19/99
	AB	6,192,596	2/27/2001	Bennett et al.	34	76	
	AC	6,117,578	9/12/2000	Lesieur et al.	429	19	
	AD	5,858,314	1999	Hsu et al.	422	211	
	AE	5,432,023	1995	Yamada et al.	429	34	
ju	AF	4,876,162	1989	McElroy	429	13	
	AG						

Foreign Patent Documents

		Document Number	Date	Country	Class	Sub-Class	Translation
ju	AH	WO 02/064248A3	2002	PCT	B01J	19/00	
	AI	WO 00/79199 A1	12/28/2000	PCT	F28D	7/00	
	AJ	WO 00/06295	2/10/2000	PCT	B01J	12/00	
	AK	EP 1031374A3	8/30/2000	Europe	B01J	8/02	No
	AL	EP 0921584 A3	1999	Europe	H01M	8/06	No
	AM	EP 1087455 A2	3/28/2001	Europe	H01M	8/04	
ju	AN	EP 0308976 A1	1989	Europe	C01B	3/34	
	AO						
	AP						

Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)

ju	AQ	PCT Search Report, mailed Oct 24, 2003, PCT/US 02/35762
ju	AR	Schubert et al., "Microstructure Devices For Applications In Thermal And Chemical Process Engineering," Microscale Thermophysical Engineering, 5:17-39, 2001.
	AS	
	AT	

Examiner

Date Considered

8/4/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.